

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tokuroh OZAWA et al.

Group Art Unit:

Application No.: New Rule 53(b) Continuation of
U.S. Application No. 10/267,834

Examiner: Not Yet Assigned

Filed: July 24, 2003

Docket No.: 100629.03

For: DISPLAY APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited by or submitted to the Office in parent application No. 10/267,834, filed October 10, 2002, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,



James A. Oliff
Registration No. 27,075

George P. Simion
Registration No. 47,089

JAO:GPS/dmw
Date: July 24, 2003
OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 100629.03		RULE 53(b) DIVISION OF APPLICATION NO. 10/267,834	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Takuroh OZAWA et al.			
				FILING DATE July 23, 2003		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
		5,714,838	2-1998	HAIGHT et al.			
		6,072,450	6-2000	YAMADA et al.			
		5,587,329	12-96	HSEUH et al.			
		5,828,429	10-98	TAKEMURA			
		6,023,307	02-00	TAKEMURA			
		5,670,792	09-97	UTSUGI et al.			
		6,011,529	01-00	IKEDA			
		5,995,073	11-99	ISAMI et al.			
		6,243,069	06-01	OGAWA et al.			
		5,869,929	02-99	EIDA et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
		EP-A1-0 653 741	05-95	Europe			
		JP-A-8-129358	05-96	Japan			
		JP 8-227276	09-96	Japan			
		JP 08 241057 A	09-96	Japan			
		EP 0112 700 A	07-84	Japan			
		WO 96 06456 A	02-96	WIPO			
		JP 08 129360 A	05-96	Japan			
		EP 0717 439 A	06-96	Europe			
		JP 08-241057 (translation only)	9-96	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
		Alan G. Lewis, et al., <u>Physical Mechanisms For Short Channel Effects In Polysilicon Thin Film Transistors</u> , IEEE, 1989, pgs. 13.4.1-13.4.4					
		Alan G. Lewis et al., <u>Polysilicon TFT Circuit Design and Performance</u> , IEEE Journal of Solid-State Circuits, December 1992, Vol. 27, No. 12, pgs. 1833-1842.					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: July 24, 2003